



App. No. 09/783,835

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/783,835
Filing Date February 14, 2001
Inventor..... Shozo Nagano et al.
Assignee..... Honeywell International Inc.
Group Art Unit..... 1742
Examiner Ip, Sikyin
Attorney's Docket No. 30-5000-(4015)-DIV3
Title: Physical Vapor Deposition Target

**RESPONSE TO NOVEMBER 18, 2003 FINAL OFFICE ACTION
AND FEBRUARY 18, 2004 ADVISORY ACTION TO ACCOMPANY RCE FILING**

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
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AMENDMENTS

Introductory Comments

In response to the Office Action dated November 18, 2003, and the subsequent
Advisory Action, applicant amends and remarks as follows.